


<b>Search Notes</b>  	<b>Application/Control No.</b>  10577100	<b>Applicant(s)/Patent Under Reexamination</b>  HEERTJES ET AL.
	<b>Examiner</b>  KIM CHU	<b>Art Unit</b>  2627

SEARCHED			
Class	Subclass	Date	Examiner
369	44.29	5/29/2008	kc
369	44.28	5/29/2008	kc
369	44.32	5/29/2008	kc
369	44.35	5/29/2008	kc
369	53.28	5/29/2008	kc
369	53.29	5/29/2008	kc
369	124.11	5/29/2008	kc
360	77.04	5/29/2008	kc
360	78.09	5/29/2008	kc

SEARCH NOTES		
Search Notes	Date	Examiner
East Search	5/29/2008	kc

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner